

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	9400	(substrate or wafer) with (height or focus or tilt) with (measur\$5 or sens\$3 or detect\$3)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/10/25 12:06
L2	240	(move or moving or moves or moved or scan\$4) with (substrate or wafer) with (tangent\$4)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/10/25 12:16
L3	10	1 and 2	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/10/25 12:14
L4	1502	(move or moving or moves or moved or scan\$4) with (substrate or wafer) with (tangent\$4 or radial)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/10/25 12:17
L5	92	1 and 4	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/10/25 12:17
L6	82	5 not 3	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/10/25 12:17

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10/25/05